

## INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449

Docket No.	Application No.			
52433/841	10/574,053			
Applicant(s)	Examiner			
YOSHINAGA et al.	Mark L. Shevin			
1 OSIIINAGA et al.	Maik L. Silevii	<u>u</u>		
Filing Date	Confirmation No.	Art Unit		

## **U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

## FOREIGN PATENT DOCUMENTS

•						TRANSLATION	
EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	Yes	No
	CN 1148416 A	April 23, 1997	CN			Abstract	
	EP 0 757 113 B1	April 12, 2000	EP				

## OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.				
	Chinese Office Action dated May 16, 2008 issued in corresponding Chinese Patent Application No. 2004800285566.				
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EXAMINER		DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.